Brooks® Model 5850TR

TR series MFC +/- 15 Vdc



Model 5850 TR



Dear Customer,

The Brooks Instrument mass flow controller you have just received is of the highest quality available, offering superior performance to the user. This controller provides the finest degree of accuracy, repeatability, and widest operating parameters available for extremely reliable gas measurement and control of mass flow rate.

Because of the wide variety of applications for mass flow controllers, we have expressly designed this instrument to provide user selectable functions in a single instrument to meet ever changing process conditions. Additionally, this "state-of-the-art" design has been packaged and materials selected to permit application to a variety of often corrosive and hostile conditions.

To realize the full potential of the inherent design flexibility and ease of maintenance, may we suggest you review this manual in its entirety.

Should you need additional information concerning the 5850 series mass flow controllers, please feel free to contact your local Brooks sales office.

We are pleased to have this opportunity of servicing you for your gas measurement and control needs.

Sincerely,

BROOKS INSTRUMENT B.V.

CAUTION

It is recommended that this publication be read in its entirely before performing any operation. Failure to understand and follow these instructions could result in serious personal injury and/or damage to the equipment.

CAUTION

This instrument contains electronic components that are susceptible to damage by static electricity. Proper handling* procedures must be observed during the removal, installation, or other handling of internal circuit boards or devices.

* Handling procedure:

- 1. Power to unit must be removed.
- 2. Personnel must be grounded, via a wrist strap or other safe, suitable means before any printed circuit card or other internal device is installed, removed or adjusted.
- 3. Printed circuit cards must be transported in a conductive bag of other conductive container. Boards must not be removed from protective enclosure until the immediate time of installation. Removed boards must be placed immediately in protective container for transport, storage, or return to factory.

COMMENTS

This instrument is not unique in its content of ESD (electrostatic discharge) sensitive components. Most modern electronic designs contain components that utilize metal oxide technology (NMOS, CMOS, etc.). Experience has proven that even small amounts of static electricity can damage or destroy these devices. Damaged components, even though they appear to function properly, exhibit early failure.

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Section 1 INTRODUCTION

1-1 PURPOSE

The Brooks Model 5850TR mass flowmeter / mass flow controller is a mass flow measuring device, designed for accurately measuring and rapidly controlling flows of gases.

1-2 DESCRIPTION

The Brooks Model 5850TR mass flow controller (M.F.C.) provides "state-of-the-art" mass flow measurement and P.I. control.

The Brooks Model 5850TR M.F.C. is used widely in the semiconductor industry as well as many others, where manual, electronic or computer controlled gas handling occurs.

The Model 5850TR consists of three basic units: a flow sensor, a control valve and an integrated electronic control system.

This combination produces a stable gasflow, selectable overshoot protection and eliminates the need for continuous monitoring and re-adjustment of gaspressures.

1-2-1 Standard user selectable features includes:

- Soft start provides a flow ramping function that effectively reduces gas flow over-/undershoot to a neglectable value. Refer to section 2-4-2.
- Remote programming permits the user to program
 the mass flow controller with an external 0-5Vdc, or
 0-10Vdc command voltage in lieu of the command
 potentiometer. Refer to section 2-4-3.
- Valve override permits the user to fully open and close the control valve independent of the command setting. Refer to section 2-4-4.
- External valve control permits the user flexibility to provide an external valve control source independent of the standard control incorporated within this mass flow controller.

Refer to section 2-4-5.

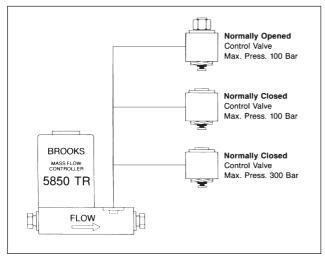


Figure 1-1. Control valve types

The 5850TR M.F.C. can be supplied with three different type control valves:

- Normally opened, max. 100 Bar operating pressure.
- Normally closed, max. 100 Bar operating pressure (std).
- Normally closed, max. 300 Bar operating pressure.

1-3 RECEIPT OF EQUIPMENT

When the equipment is received, the outside packing case should be checked for any damage incurred during shipment.

If the packing case is damaged, the local carrier should be notified at once regarding his liability.

A report should be submitted to the product service department, Brooks Instrument / Rosemount. Refer to the cover for full address.

Remove the envelope containing the shipping list. Carefully remove the equipment from the packing case. Make sure spare parts are not discarded with the packing material.

1-4 RETURN SHIPMENT

Do not return any assembly or part without a return material report. The return material report is available from all district sales offices and the product service department.

Information describing the problem, corrective action, if any, and the work to be accomplished at the factory must be included.

1-5 RECOMMENDED STORAGE PRACTICE

If intermediate or long term storage is required for equipment, as supplied by Brooks Instrument B.V., it is recommended that said equipment be stored in accordance with the following:

- 1. Within the original shipping container.
- Stored in a sheltered area, preferably a warm, dry, heated warehouse.
- 3. Ambient temperature (21°C Nominal, 32°C max. / 7°C min.)
- 4. Relative humidity 45% Nominal (60% max., 25% min.)

Upon removal from storage, a visual inspection should be conducted to verify the condition of equipment is "as received".

If the equipment has been in storage for an excess of ten (10) months or in conditions in excess of those recommended, all pressure boundary seals should be replaced and the device subjected to a pneumatic pressure in accordance with the applicable vessel codes.

1-6 SPECIFICATIONS

Certification EMC directive (89/336/EEC)

EN 61326-1:1997+ A1:1998

Certified for Zone II environment according to: KEMA 03ATEX1531 X per EN 60079-15:2003



II 3 G EEx nA II T4

Performance

Accuracy ± 1% full scale including linearity measured at calibrated conditions

Repeatability ±

± 0.25% full scale 50 to 1

Rangeability Temperature

0.1% full scale/°C

coefficient Mounting

attitude sensitivity

Flow ranges

 \pm 0.5% full scale maximum deviation from specified accuracy

Any full scale range from 10 ml_n/min.

to 20I_n/min. Based on Nitrogen equivalent.

Flow output/ setpoint input 0-5 Vdc, min. load: 1000 Ohm

Ratings

Max. operating 100/300 bar versions

pressure

Temperature Ambient/gas 0-65°C

Leak integrity Outboard: 1 x 10-6 mbar.l/s

Helium

Power requirements

Materials of

Materials of construction Mechanical connections

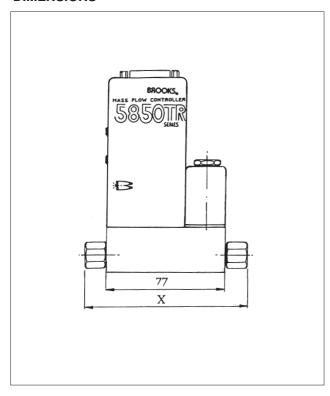
Electrical connection

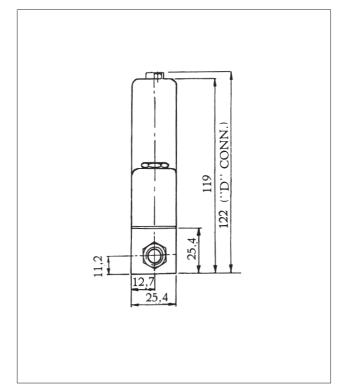
+ 15 Vdc (± 5%) at 25 mA and - 15 Vdc (± 5%) at 180 mA

Wetted parts stainless steel with Viton®, PTFE, Buna-N® or Kalrez® Standard fittings: 1/4" VCR, 1/4" VCO, 1/4" NPT, 1/8" or 1/4" tube compression

Sub-D-type connector (goldplated contacts) with 3 m or 6 m cable

DIMENSIONS





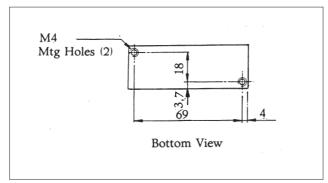


Figure 1-6.

Connections	Dim.X
⁹ /16" - 18 UNF	77
1/4" TB COMPR.	129
¹ /8" TB COMPR.	124
1/4" VCR	125
1/4" VCO	117
1/4" NPT	118
6 mm TB COMPR.	129

Note: Dimensions are in mm.

1-7 STANDARD MANUFACTURING PROCEDURES

Brooks Instrument warranties the supply of very high quality flow measurement and control equipment. Upon receipt of incoming materials, till shipment of instruments, fabrication of the BROOKS MASS FLOW CONTROLLERS are monitored at every production stage.

Pressure test, each mass flow controller is pressure tested at 1,5 times the maximim working pressure.

Burn-in test, each instrument undergoes a temperature burn-in test for 16 hours. In this time the instruments are continuously tested under severe conditions.

Calibration, in our calibration department the instruments are calibrated in accordance with the customers requirements.

Brooks Instrument uses their patented VOL-U-METER, and BELL PROVER calibration equipment, which are used as a **primary standard**, certified by the National Bureau of Standards.

Helium leak-test, when the mass flow controllers have been calibrated, the instruments are subject to a leak test, using a Helium leak detector. Sensitivity: 1 x 10⁻¹¹ ml/sec. He.

For model 5850TR, Brooks warranties an inboard outboard leak integrity: 1 x 10-6 m.bar. I/sec. of Helium.

Final inspection, The instruments are visually inspected, indentified for serial control and completed with a calibration certificate.

E.S.D. package, each mass flow controller is carefully packed in a specially designed electro static discharge box, provided with a sticker for serial control.

Section 2 INSTALLATION

2-1 GAS CONNECTIONS

Standard inlet and outlet connections supplied with Model 5850TR are 1/4" tube compression fittings, for flowrates up to 10 In/min. and 3/8" tube compression fittings for higher flowrates, 6 mm tube compression fittings, 1/4"-VCO, 1/4"-VCR, 1/4"-NPT, or 1/8" tube compression fittings are available upon request.

Prior to installation, make certain all piping is clean and free of obstruction. Install the piping in such a manner that permits easy removal if the instrument has to be removed for cleaning, or bench troubleshooting.

2-2 IN-LINE FILTER

It is recommended an in-line filter be installed upstream and sometimes downstream from the flowsensor to prevent the possibility of any foreign material entering the mass flow sensor or controller. The filter element should be periodically replaced or may be ultrasonically cleaned.

Refer to table: 2-2

Maximum Flow Rate		Recommended Filter Size
100 i	ml _n /min.	1 micron
500 1	ml _n /min.	2 micron
1or 5	I _n /min.	7 micron
10 or 20	I _n /min.	15 micron

Table 2-2. Recommended filter size

2-3 INSTALLATION

CAUTION: When installing the controller, care should be taken that no foreign materials enter the inlet or outlet of the instrument. Do not remove the protective end caps until time of installation.

Recommended installation procedures:

- A. The Model 5850TR should be located in a clean dry atmosphere relatively free from shock and vibration .
- B. Leave sufficient room for access to the electrical components.
- C. Install in such a manner that permits easy removal if the instrument requires cleaning.

CAUTION: When used with a reactive (sometimes toxic) gas, contamination or corrosion may occur as a result of plumbing leaks or improper purging. Plumbing should be checked carefully for leaks and the controller purged with dry Nitrogen before use.

D. The Model 5850TR mass flow controller can be installed in any position.

However, mounting orientations other than the original factory calibration (see data sheet) will result in a \pm 0,25% maximum full scale shift.

NOTE: The control valve in the Model 5850TR provides precision control and is not designed for positive shut off. If positive shut off is required, it is recommended that a separate shut-off valve be installed in-line.

CAUTION: Since the Model 5850TR control valve is not a positive shut-off, a separate solenoid valve may have been installed for that purpose. It should be noted that a small amount of gas may be trapped between the downstream side of the mass flow controller and the solenoid resulting in a surge upon actuation of the controller. This surge can be reduced in magnitude by locating the controller and solenoid valve close to gether or by moving the solenoid valve upstream of the controller.

2-4 ELECTRICAL CONNECTION

(Refer to figures 2-4 and 2-5)

The 5850TR can be supplied with a 15-pins "D"-connector suitable for round cable connections.

The Brooks (electrical/electronic) equipment bearing the CE mark has been successfully tested to the regulations of the Electro Magnetic Compatibility (EMC directive 89/336/EEC).

Special attention however is required when selecting the signal cable to be used with CE marked equipment.

Quality of the signal cable and cable connectors:

- Brooks standard supplies high quality cable(s) which meets the specifications for CE certification.
- If you provide your own signal cable you should use a cable which is overall completely screened with at least an 100% shield.

Cable connectors used should be made from metal and cable glands should either be metal or metal shielded.

The cable screen should be connected to the metal connector or gland and shielded at both ends over 360 degrees.

For pin configuration; please refer to figure 2-5.

2-4-1 Setpoint

The command potentiometer (if used) may be furnished with the instrument or may be supplied by the user. The potentiometer should be a 1 K-ohm or 5 K-ohm 10-turn precision potentiometer with 0,25% linearity. (Beckman 7240 Series or equivalent.)

"D" connections: refer to figures 2-4 and 2-5.

2-4-2 Soft Start (standard option, for controller only) To enable Soft-Start: connect pin 15 to pin 3 or 9. To disable Soft-Start: disconnect pin 15 from pin 3 or 9.

2-4-3 Remote Programming

If the controller is to be programmed for an external 0-5 Vdc command voltage, the command potentionmeter is not used.

The external command voltage (+) is applied to the command signal and (-) to the command signal return.

refer to figure 2-5: command signal to pin 8

command signal return to pin 1.

2-4-4 Valve Override

It is possible to drive the control valve fully open or close, independent of the controller position.

Control valve normally closed	Opened	Closed
Sub "D" p.v.v., pin 12	+15 Vdc	-15 Vdc
Sub "D" n.v.v., pin 12	-15 Vdc	+15 Vdc

Control valve normally opened	Opened	Closed
Sub "D" p.v.v., pin 12	-15 Vdc	+15 Vdc
Sub "D" n.v.v., pin 12	+15 Vdc	-15 Vdc

2-4-5 External valve control

It is possible to drive the valve with an external P.I. controller. This can be enabled by removing Jumper J2 a-b and inserting Jumper J2 a-c.

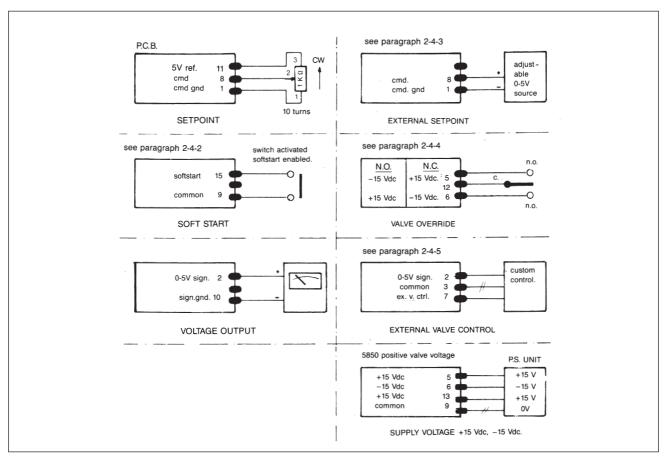


Figure 2-4. 5850TR Hook-up diagrams 15 pins sub "D"-connector

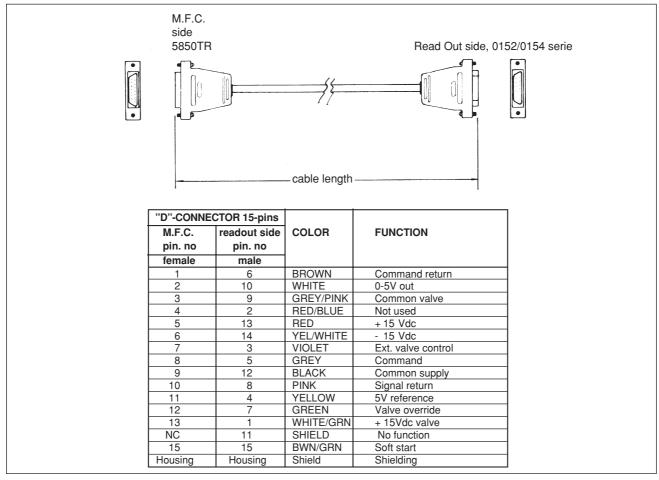


Figure 2-5. 5850TR connections diagram "D"-connector

Section 3 OPERATION

3-1 THEORY OF OPERATION

The thermal mass flow sensing technique used in the 5850TR works as follows:

A precision power supply provides a constant power heat input (P) at the heater, which is located at the midpoint of the sensor tube. Refer to figure 3-1. At zero, or no flow conditions the heat reaching each temperature sensor is equal. Therefore the temperatures T1 and T2 are equal. When gas flows through the tube the upstream sensor is cooled and the downstream sensor is heated, producing a temperature difference. The temperature difference T2-T1, is directly proportional to the gas mass flow. The equation is: $\Delta T = A * P * Cp * m$

Where:

 ΔT = Temperature difference T2-T1 (K)

Cp = Specific heat of the gas at constant pressure (kJ .kg⁻¹ . K⁻¹)

P = Heater power (kJ/s)

m = Mass Flow (kg/s)

A = Constant of proportionality (S^2-K^2/kJ^2)

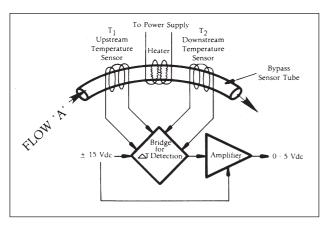


Figure 3-1. Flow sensor operational diagram

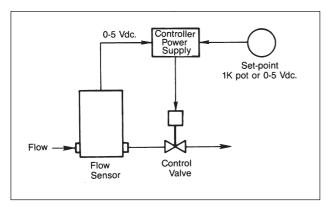


Figure 3--2. Control system blockdiagram

A bridge circuit interprets the temperature difference and a differential amplifier generates a linear 0-5 Vdc signal directly proportional to the gas **mass flow rate**. A flow restrictor performs a ranging function similar to a shunt resistor. This restrictor provides a pressure drop that is linear with flow rate. The sensor tube has

the same linear pressure drop/flow relationship. The ratio of the restrictor flow to the sensor tube flow remains constant over the range of the meter. Different restrictors have different pressure drops and produce meters with different full scale flow rates. The span adjustment in the electronics affects the fine adjustment of the meters full scale flow.

The printed control board offers you the following features:

- soft start
- valve override and a setpoint input for 0-5Vdc or 0-10 Vdc signal, or a command potentiometer.
- precision reference voltage is provided to drive the command potentiometer.

The voltage is presented to the wiper by the voltage divider action and is applied to the command input of the controller.

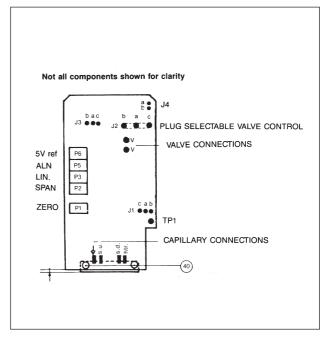


Figure 3-3. Printed circuit board assy "D"-connector

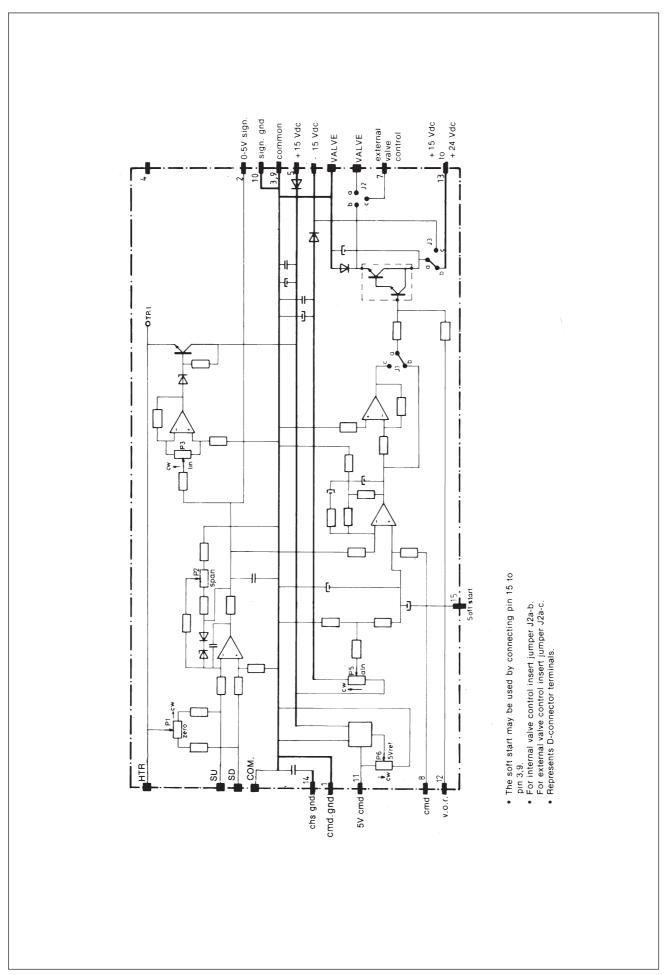


Figure 3-4. Schematic diagram 5850TR electronics with "D"-connector

3-2 OPERATING PROCEDURE (refer to figures 2-2 to 2-5 customer hook-up diagram).

- A. Apply power to the M.F.C. and allow approximately 45 minutes for the instrument to warm up and stabilize.
- B. Turn on gas supply.
- C. Command 0% flow and observe the controllers output signal.
 - The output should be slightly positive: + 15 mVdc for the N.C. Valve and + 100 mVdc for the N.O. Valve.
- D. Set command for desired flowrate to assume normal operation.

3-3 ZERO ADJUSTMENT

Each 5850TR is factory adjusted to provide a + 15 mVdc signal at zero flow. The adjustment is made in our calibration laboratory which is temperature controlled. After initial installation and warm-up in the gas system the zero flow indication may be other than the factory setting. This is primarily caused by changes in temperature between our calibration laboratory and the final installation. The zero flow reading can also be affected to a small degree by changes in line pressure and mounting attitude. To check zero always mount the controller in its final configuration and allow a minimum of 20 minutes for the temperature of the controller and its environment to stabilize. Use a suitable voltmeter check the controller output signal. If it differs from the factory setting adjust it by removing the lower pot hold plug, which is located closest to the controller body. Adjust the zero potentiometer (refer to figure 3-3) until the desired output signal is obtained.

3-4 CALIBRATION PROCEDURE (refer to figures 3-3 to 3-6).

NOTE:

Calibration of the 5850TR mass flow controller requires the use of a digital voltmeter (D\IM) and a primary flow standard calibrator such as the Brooks Vol-U-meter $^{\odot}$.

It is recomded that the calibration should be performed only by trained and qualified service personnel.

If the mass flow controller is to be used on a gas other than the calibration gas, apply the appropriate sensor conversion factor. Size the orifice for actual operating conditions.

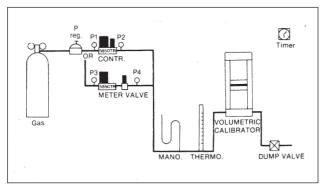


Figure 3-5. Typical calibration installation

The calibration procedure is written for all M.F.C. models, please refer only to those chapters which are applicable.

With the meter installed in an unpressurized gas line, apply power and allow approximately 45 minutes for warming up. Adjustment and calibration check procedures do not allow the control valve to open when gas flow is not present. This situation is not a normal operation mode, it will cause the control valve to heat up abnormally. A meter with an abnormally warm valve will be difficult to calibrate. This situation can be prevented by switching the valve override "closed" when there is no gas flow. Also avoid unnecessary periods with the valve override "open".

1-Reference, P6

Ref. adjustment. -Connect D.V.M. positive lead to the command potentiometer terminal CW.

Pin 11 and negative to command pin 1.
 Adjust Ref P6 for 5.000 V.

2-Zero, P1

ZERO adjustment - Connect DVM positive to the output and DVM negative to the signal common. Adjust Zero, P1 for \pm 15 mV \pm 2 mV.

3-Alignment, P5

ALN. adjustment- Set command potentiometer to 100%. Adjust ALN P5 for 5.000V flow output.

 Connect positive lead to the output pin 2 and negative to pin 10.

4-Total Error

Set the command potentiometer to 10% of ref. voltage (0,500V)

Check and record output reading. The difference (in millivolts) between the command and output is "total error".

5-Alignment, P5

ALN adjustment, P5 to minus one-half of error.

6-Linear, P3

LIN adjustment. -Set command potentiometer to 100%, with DVM connected to TP1, adjust LIN (P3) for 11,0V.

7-Span, P2

SPAN adjustment -With command potentiometer at 100%, using suitable volumetric calibration equipment, adjust SPAN P2 for proper full scale flow.

8-Zero, P1

Set command potentiometer to 0% of flow. Connect DVM positive to output and readjust zero (P1) for $15\text{mV} \pm 2\text{mV}$.

9-LIN adjustment

Set command potentiometer to 50% of flow and measure the flow rate using suitable volumetric calibration equipment.

Calculate the error as a percentage of full scale.

Full scale error =
$$\frac{100\% \text{ (measured flow rate-desired flow rate)}}{\text{F.s. flow rate}}$$

Example:

What is the percent of full scale error when $F.s. = 100 \text{ ml}_n/\text{min}$.

Measured flow rate = $51,5 \text{ ml}_n/\text{min}$. Desired flow rate = $50,0 \text{ ml}_n/\text{min}$. Full scale error = $\frac{100 (51,5-50)}{100} = 1,5\%$

Note:

If the result of the percentage of error calculation is negative, be sure the "negative" percentage of error is used when calculating the TP1 voltage.

10-

Set command potentiometer to 100% of flow. Note the voltage at TP1. Calculate the new TP1 voltage: (the error from step 9) times (-0,178 V/%).

Example:

If step 9 error = 1,5% and TP1 voltage = 11,000V Then the new TP1 = 1,5% x $(-0,178 \text{ V/\%})^* + 11V$ = -0,267 V + 11V = 10.733 V

11- Adjust LIN (P3) for new TP1 voltage.

12-

Repeat steps 7, 8 and 9. If the error from step 9 is less than 0,5% then calibration is complete. If not, then repeat steps 10, 11 and 12.

3-5 SIZING OF CONTROL VALVE

When a change of the flow conditions is required; it may be necessary to change the flowrestrictor (refer to par. 4-4) and orifice size.

When calculating the Kv-value following informatior is required.

For proper sizing following information is required:

 $\begin{array}{lll} \mbox{Upstream pressure} & \mbox{P1 (Abs) Bar} \\ \mbox{Downstream pressure} & \mbox{P2 (Abs) Bar} \\ \mbox{Gas temperature} & \mbox{T (Kelvin)} \\ \mbox{Maximum flow} & \mbox{Q (m3n/h)} \\ \mbox{Gas density} & \mbox{φ (kg/m3n)$} \end{array}$

Depending on the ratio between P1 and P2, we have to make different calculations:

• Over critical, when
$$\frac{P2}{P2} > 0.5$$

Kv = $\frac{Q \text{ max.}}{514}$ x $\sqrt{\frac{\varphi \text{ x T}}{(P1-P2) \text{ x P2}}}$

• Under critical, when
$$\frac{P2}{P2} \le 0.5$$

$$Kv = \frac{Q \text{ max.}}{257 \times P1} \times \sqrt{\varphi \times T}$$

The table 3-5-1 refers to the Kv-values and appropriate orifice sizes.

The next largest orifice size should be selected in case of interpolation.

3-5-1- Kv-Values and max. Acceptable Pressure Drop over the Valve

		-	
Kv value (m3n/h)	Orifice diameter (inch)	Max. ∆P(Bar)	Partnumber
5 x 10 ⁻⁶	0,0013"	500	577-Z-363-BMT
2 x 10 ⁻⁵	0,002"	500	577-Z-364-BMT
5 x 10 ⁻⁵	0,003"	350	577-Z-365-BMT
11 x 10 ⁻⁵	0,004"	230	577-Z-366-BMT
18 x 10 ⁻⁵	0,005"	160	577-Z-367-BMT
4 x 10 ⁻⁴	0,007"	100	577-Z-368-BMT
9 x 10 ⁻⁴	0,0010"	60	577-Z-369-BMT
2 x 10 ⁻³	0,0014"	36	577-Z-401-BMT
4,7 x 10 ⁻³	0,0020"	22	577-Z-370-BMT
1,05 x 10 ⁻²	0,0028"	13	577-Z-371-BMT
1,4 x 10 ⁻²	0,0032"	11	577-Z-372-BMT
3,3 x 10 ⁻²	0,0048"	6	577-Z-137-BMT

^{*}A linearity adjustment factor units = volts/percent.

Section 4 MAINTENANCE

4-1 GENERAL

No routine maintenance is required on the model 5850 TR other than an occasional cleaning. If an in-line filter is used, the filtering element should periodically be replaced or ultrasonically cleaned.

4-2 CONTROLVALVE (refer to figure 5-1)

The control valve may be disassembled in the field by the user for cleaning or servicing. Disassemble the valve as follows:

- 1. remove the jam nut (14) on top of the valve assembly.
- 2. remove the screw (5) and cover (3) of the controller.

- 3. remove the coil housing (13), (including item 12 and 11).
- 4. carefully remove the stem assembly (1) as not to be bend the lower guide spring (9).
- 5. remove plunger assembly (16).
- 6. remove orifice (19).

Clean the parts and carefully assemble in reverse of the above procedure.

O-ring seals should be inspected and may need to be replaced during the maintenance procedure.

O-ring seals must be lubricated with HALO-CARBON 25-10M grease prior to installation.

NO LUBRICATION SUBSTITUTE IS RECOMMENDED.

Trouble	Possible cause	Check corrective action
	No power in	1. Check for + 15 Vdc power supply
NO OUTPUT	Obstruction in sensor	Flush sensor in both directions with non-residuous solvent. Air dry thoroughly. Do not attempt to service or disassemble sensor. Return to factory
	P.C. Board failure	1. Return to factory.
	Gas leak	Check downstream gas connection Return to factory
	P.C. Board failure	1. Return to factory.
	Gas leak	Check all gas connections
	Dirty sensor	Flush with non-siduous solvent Air dry thoroughly. Do not attempt to service or disassemble sensor Return to factory.
	Change in composition of metered gas	Refer to table 4-4-1 for conversion factor Return to factory.
	P.C. Board failure	1. Return to factory.
	Clogged restrictor	Ultrasonically clean. Replace restrictor.

If any of the above services are performed, it is recommended calibration of the unit be verified using suitable volumetric calibration equipment.

4-3 TROUBLE SHOOTING

CAUTION: It is important that this instrument be serviced only by properly trained and qualified personnel.

System Checks

The 5850TR is generally used as a component in gas handling systems which can be quite complex. This can make the task of isolating a malfunction in the system a difficult one. An incorrectly diagnosed malfunction can cause many hours of unnecessary downtime. If possible, make the following system checks before removing a suspected defective mass flow controller for bench troubleshooting or return, especially if the system is new:

- 1. Verify that the process gas fittings have been correctly connected and leak checked.
- If the mass flow controller appears to be functioning but cannot achieve set-point, verify that sufficient inlet pressure and pressure drop are available at the controller to provide the required flow.

WARNING:

If it becomes necessary to remove the controller from the system after exposure to toxic, pyrophoric, flammable, or corrosive gas, purge the controller thoroughly with dry inert gas such as Nitrogen, before disconnecting the gas connections. Failure to correctly purge the controller could result in fire, explosion, or death. Corrosion or contamination of the mass flow controller upon exposure to air may also occur.

4-4 USE OF THE CONVESION TABLES

If a Mass Flow Meter or Controller is operated on a gas other than the gas it was calibrated with, a scale shift will occur in the relationship between the output signal and the mass flow rate as a result of the difference in heat capacities between the two gases.

This scale shift can be calculated by using the ratio of the molar specific heat of the two gases, or the sensor conversion factor.

The gasconversion table is available at Brooks Instrument under document no.: J-836-D-508.

<u>USE OF A MFC/M FOR A DIFFERENT GAS THAN</u> IT IS CALIBRATED FOR:

For use with a different gas type, multiply the output reading by the ratio of the gas factor of the desired gas and the gas factor of the calibrated gas.

Actual gas Output Flow rate = Reading x

factor of the new gas

factor of the calibrated gas

Example:

The controller is calibrated for nitrogen: $1000 \, \text{ml}_{\text{n}} / \text{min}$ full scale.

The desired gas is carbon dioxide.

Multiply the output reading by 0.773 to calculate the flow of carbon dioxide.

When the output reading is 750 ml_n/min, the flow rate for carbon dioxide

is $750 \times 0.773 = 579.75 \text{ ml}_n/\text{min}$.

CALCULATE GAS FACTOR FOR MIX GASSES:

In order to calculate the conversion factor for a gas mixture the following formula should be used:

 $\begin{array}{c} Sensor \\ conversion = \\ factor for \\ Mixture \\ \end{array} \begin{array}{c} \begin{array}{c} 100 \\ \hline P1 \\ sensor \\ conversion \\ conversion \\ factor 1 \end{array} \begin{array}{c} P2 \\ + sensor \\ + sensor \\ conversion \\ factor 2 \end{array} \begin{array}{c} Pn \\ + sensor \\ conversion \\ factor n \end{array}$

Where P1 = percentage (%) of gas 1 (by volume) P2 = percentage (%) of gas 2 (by volume)

Pn = percentage (%) of gas n (by volume)

Example:

The desired gas is 20% Helium (He) and 80% Chlorine ($\mathrm{Cl_2}$) by volume. The desired full-scale flow rate of the mixture is 20 $\mathrm{I_n/min}$.

Sensor conversion factor for the mixture is:

Mixture Factor =
$$\frac{100}{20 + 80} = 0.946$$

1.386 0.876

 N_2 equivalent flow = 20/0.946 = 21.14 I_n /min .

NOTE:

It is generally accepted that the mass flow rate derived from this equation is only accurate to \pm 5%. The table below lists the conversion factors for various gases with respect to nitrogen. The conversion table is used to determine the flow rate for gases other than the pre-selected gas. The flow meter is factory set to a pre-selected gas, pressure and flow range.

Acetylene (Eltyne)	Source J-836-D-508 Rev.14	Source J-836-D-508 Rev.14				
Almene C3H4 0,478 1,199 1,1787 Almonoini NH3 0,786 0,781 0,771 Armonoini NH3 0,786 0,781 0,777 Armonoini NH3 0,781 0,781 0,781 0,777 Armonoini NH3 0,781	Acatulana (Ethuma)	Formula	Gasfactor	Orifice factor	Density (kg/m3)	
Allene						
Ammonia NH3						
Argon Argon Arine Asha Arsine Asha Asha Asha Asha Asha Asha Asha Asha			1 '			
Arsine BC13 0.443 0.754 1.661 3.478 BORON Trithoride BC13 0.443 1.2044 5.227 Boron Trithoride BC13 0.443 1.2044 5.227 Boron Finithoride BC3 0.479 1.569 3.025 7.005 Boron Finithoride BC3 0.487 1.569 3.025 7.005 BC0mme Finithoride BC3 0.487 2.502 7.7005 BC0mme Finithoride BC3 0.487 2.502 7.7005 BC0mme Finithoride BC3 0.489 2.247 7.7005 BC0mme Finithoride CC4H6 0.354 1.413 2.491 7.435 2.503 BC0mme Finithoride CC4H6 0.354 1.413 2.491 7.435 2.503 BC0mme Finithoride CC4H8 0.2294 1.435 2.503 BC0mme Finithoride CC4H8 0.320 1.435 2.503 BC0mme Finithoride CC4H8 0.320 1.435 2.503 BC0mme Finithoride CC4H8 0.320 1.435 2.503 BC0mme Finithoride CC4H 0.344 2.345 8.680 BC0mme Finithoride CC4H 0.344 2.345 8.680 BC0mme Finithoride CC4H 0.344 2.345 8.680 BC0mme Finithoride BC0mme	Argon		1 '		'	
Boron Frithoride BF3		AsH3	0,754	1,661	3,478	
Bromine Printsfluoride BrF5 0,287 2,502 7,806 Bromnto Trifluoride BrF3 0,439 2,214 6,108 Bromntoffluoroethylene C28Fr3 0,326 2,397 7,165 Bromotrifluoroethylene C48Fr3 0,326 2,397 7,165 C47 C	Boron Trichloride	BCL3	0,443	2,044	5,227	
Bromnir Influoride						
Bomontifusoremethane (H-19B1)						
Bomortifluoromethane (I-13B1)						
1.3 Butadiene					1 '	
Butane	, ,				1 '	
1-Butene						
CIS-2-Eutone						
Trans-2-Butene						
Carbon Dioxide				l '		
Carbon Monoxide CS2 0,838 1,650 3,393 Carbon Monoxide CO 0,995 1,000 1,250 Carbon Tetrachloride CCL4 0,344 2,345 6,860 Carbon Tetrachloride CDF2 0,567 1,555 2,045 Carbonyl Fluoride CDF2 0,567 1,555 2,045 Carbonyl Sulfide CDS 0,680 1,463 2,680 Chlorine CL2 0,869 1,598 3,214 Chlorider CL2 0,869 1,598 3,214 Chlorider Christore CLD 0,689 1,594 3,011 Chlorider Christore CLD 0,689 1,594 4,125 Chlorofribrorethlane (F-22) CHCLP2 0,505 1,770 3,906 Chlorofribrorethlane (F-15) C2CLF5 0,243 2,937 7,165 Chlorofribroremethane (F-113) CCLF3 0,337 2,044 5,208 Chlorofribroremethane (F-128) CAHBCL 0,234 1,818 4,13						
Carbon Tetrachloride CCL4 0.344 2.345 6,860 Carbon Tetrachloride (1-1) CF4 0.440 1,770 3,926 Carbonyl Fluoride COF2 0.567 1,555 2,045 Carbonyl Sulfide COS 0.880 1,463 2,680 Chlorine CL2 0.876 1,598 3,214 Chlorine Dioxide CLC2 0.833 1,554 3,011 Chloride Trifluoride CLC3 0.433 1,812 4,125 Chlorofiluoroembane (F22) CHCLF2 0.505 1,770 3,906 Chlorofiluoroembane (F15) C2CLF3 0,243 2,997 7,185 Chlorofiluoroembane (F15) C2CLF3 0,337 2,044 5,208 Chlorofiluoroembane (F13) CLCF3 0,337 2,044 5,208 Chlorofiluoroembane (F13) CLCF3 0,490 1,885 4,912 2-Chlorobutane CAHGCL 0,234 1,818 4,134 Cyangen CKN 0,488 1,366 <t< td=""><td>Carbon Disulfide</td><td>CS2</td><td></td><td></td><td></td></t<>	Carbon Disulfide	CS2				
Carbon Terior Carbon Terior Carbon Terior Carbon Terior Carbon Terior Carbon Terior Carbon Sulfide COF2	Carbon Monoxide	CO	0,995	1,000	1,250	
Carbony Fluoride	Carbon Tetrachloride		0,344		6,860	
Carbonyl Sulfide						
Chlorine CL2						
Chlorine Dioxide						
Chlorine Trifluoride						
Chlorodifluoromethane (f-22)					1 '	
Chloroform (Trichloromethane)						
Chloropentalfluoroethane (f-115)						
Chlorotrifluoromethane (f-13)	,					
Chlorotrifluoromethane (f-13)						
2-Chlorobutane						
Cyanogen (CN)2 0.488 1,366 2,322 Cyanogen Chloride CLCN 0,618 1,480 2,730 Cyclobutane C4H8 0,387 1,413 2,491 Cyclopropane C3H6 0,505 1,224 1,877 Deuterium D20,995 0,379 0,177 Diborane Gillouromethane (F-12B2) CBr2F2 0,363 2,652 8,768 1,2-Dibromotetrafluoroethane (F-114B2) CBr2F2 0,363 2,652 8,768 1,2-Dibromotetrafluoroethane (F-21) CCL2F2 0,390 2,099 5,492 Dichlorodifluoromethane (F-21) CHCL2F 0,456 1,985 4,912 Dichlorosilane SH2CL2 0,456 1,985 4,912 Dichlorosilane CHCL2F3 0,456 1,985 4,912 </td <td></td> <td></td> <td></td> <td></td> <td></td>						
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Diborane		C3H6			1,877	
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	Hexane					
			•	·	·	

Hydrogen	H2	1,008	0,269	0,090
Hydrogen Bromide	HBr	0,987	1,695	3.645
Hydrogen Chloride	HCL	0,983	1,141	1,639
	HCN		0.973	1,179
Hydrogen Cyanide		0,744	· 1	
Hydrogen Fluoride	HF	0,998	0,845	0,893
Hydrogen lodide	HI	0,953	2,144	5,789
Hydrogen Selenide	H2Se	0,837	1,695	3,613
Hydrogen Sulfide	H2S	0,850	1,108	1,539
	IF 5			
lodine Pentafluoride		0,283	2,819	9,907
Isobutane	C4H10	0,260	1,440	2,596
Isobutene	C4H8	0,289	1,435	2,503
Isopentane	C5H12	0,211	1,605	3,222
Krypton	Kr	1,382	1,729	3,708
Methane	CH4	0,763	0,763	0,717
Methylacetylene	C3H4	0,473	1,196	1,782
Methyl Bromide	CH3Br	0,646	1,834	4,236
3-Methyl-1-butene	C5H10	0,252	1,584	3,127
Methyl Chloride	CH3CL	0,687	1,347	2,308
Methyl Fluoride	CH3F	0,761	1,102	1,518
Methyl Mercaptan	CH4S	0,588	1,313	2,146
Methyl Silane	CH6Si	0,393	1,283	2,061
Methyl Trichlorosilane	CH3CL3Si	0,267	2,310	6,675
1 '			1,435	
Methyl Vinyl Ether	C3H6O	0,377	· ·	2,567
Monoethyanolamine	C2H7NO	0,305	1,477	2,728
Monoethylamine (CH3CH2NH2)	C2H7	0,359	1,269	2,013
Monomethylamine	CH3NH2	0,565	1,067	1,420
Neon	Ne		0,847	0,902
	-	1,398		
Nickel Carbonyl	Ni(CO)4	0,212	2,371	7,008
Nitric Oxide	NO	0,995	1,030	1,339
Nitrogen	N2	1,000	1,000	1,251
Nitrogen Dioxide	NO2	0,758	1,713	2,052
Nitrogen Trifluoride	NF3	0,501	1,598	3,168
Nitrogen Trioxide	N2O3	0,443	1,649	3,389
Nitrosyl Chloride	NOCL	0,644	1,529	2,913
Nitrous Oxide	N2O	0,752	1,259	1,964
Octofluorocyclobutane	C4F8	0,169	2,672	8,933
Oxygen	02	0,988	1,067	1,429
Oxygen Difluoride	OF2	0,672	1,388	2,402
Ozone	O3	0,738	1,310	2,138
Perchloryl Fluoride	CLO3F	0,448	1,905	4,571
Perfluorobutane	C4F10	0,738	2,918	10,610
Perfluoro-2-Butene	C4F8	0,268	2,672	8,933
Perfluoromethyl-vinylether (PMVE)	PMVE	0,296	2,029	5,131
	C3F8			
Perfluoropropane		0,179	2,591	8,396
Pentane (n-Pentane)	C5H12	0,212	1,605	3,222
Pentafluoroethane	C2HF5	0,287	2,070	5,360
Phosgene	COCL2	0,504	1,881	4,418
Phosphine	PH3	0,783	1,100	1,517
				l '
Phosphorous Pentafluoride	PF5	0,346	2,109	5,620
Phosphorous Trifluoridide	PF3	0,495	1,770	3,906
Propane (same as CH3CH2CH3)	C3H8	0,343	1,274	2,008
Propylene (Propene)*	C3H6	0,401	1,234	1,875
Rhenium Hexafluoride	ReF6	0,230	3,279	13,410
				l '
Silane	SiH4	0,625	1,070	1,440
Silicon Tetrachloride	SiCL4	0,310	2,462	7,579
Silicon Tetrafluoride	SiF4	0,395	1,931	4,648
Sulfur Dioxide	SO2	0,728	1,529	2,858
Sulfur Hexafluoride	SF6	0,270	2,348	6,516
Sulfur Tetrafluoride	SF4	0,353	1,957	4,776
Sulfur Trioxide	SO3	0,535	1,691	3,575
Sulfuryl Fluoride	SO2F2	0,423	1,931	4,648
Tetrachloromethane	CCL4	0,344	2,345	6,858
				'
Tetrafluoroethylene (TFE)	C2F4	0,361	1,905	4,526
Tetrafluorohydrazine	N2F4	0,367	1,926	4,624
Trichlorofluoromethane (f-11)	CCL3F	0,374	2,244	6,281
Trichlorosilane	SiHCL3	0,329	2,201	6,038
				l '
Trimethyloxyborane (TMB)	B(OCH3)3	0,300	1,929	4,638
1,1,2-Trichloro-1,1,2-Triflouroet (f-113)	C2CL3F3	0,231	2,520	7,920
Trimethylamine	(CH3)3N	0,316	1,467	2,639
Tungsten Hexafluoride	WF6	0,227	3,264	13,280
	UF6			
Uranium Hexafluoride		0,220	3,548	15,700
Vinyl Bromide	C2H3Br	0,524	1,985	4,772
Vinyl Chloride	C2H3CL	0,542	1,492	2,788
Vinyl Fluoride	C2H3F	0,576	1,281	2,046
Water Vapor	H2O	0,861	0,802	0,804
				0,004
Xenon	Xe1,383	2,180	5,851	1

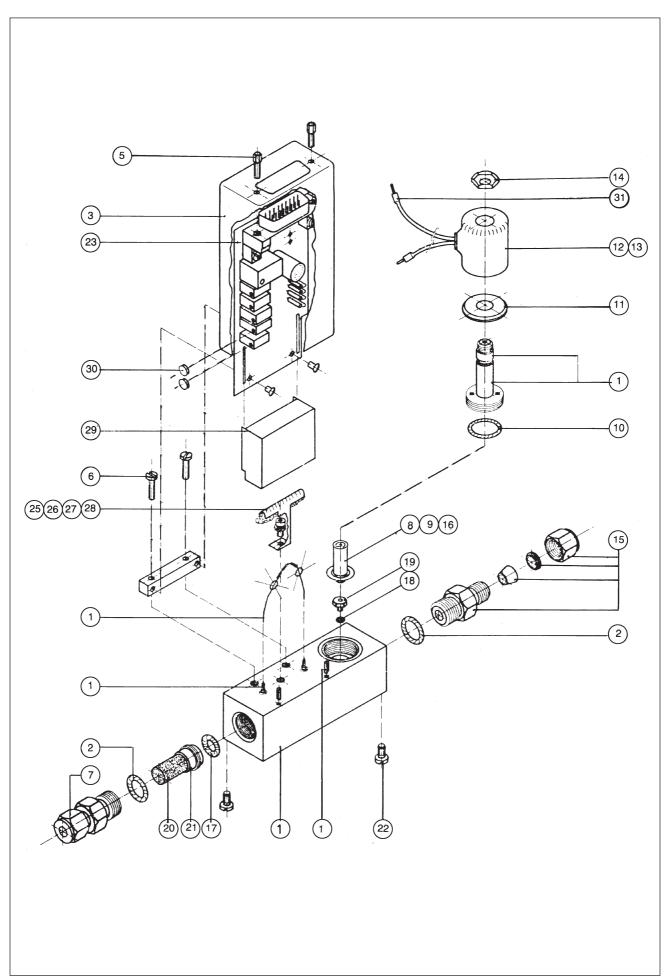


Figure 5-1. Exploded view 5850TR

5-1 RECOMMENDED SPARE PARTS 5850TR WITH N.C. VALVE, 100 BAR

Ref. no.	Quantity required	Description	Part number
1	1	Transducer body M.F.C. Sensor	092-B-033-BMA 092-B-036-BMA
2	2	O-ring for adapters Viton Teflon Buna-N	375-B-906-QTA 375-B-906-QMA 375-B-906-SUA
3	1	Housing cover Card Edge connection sub "D"-connection sub "D"-connection (sensor)	219-Z-190-EAA 219-Z-241-EAA 219-Z-243-EAA
5	2 1	Cil. screw Card Edge connection Mounting set sub "D"-connection	753-G-267-AAA 760-Z-037-ACS
7	1	Inlet Adapters (incl. filter) 1/4" tube comp. fittings 1/8" tube comp. fittings 1/4" VCR 1/4" NPT 6 mm tube comp. fittings 3/8" tube comp. fittings	320-B-080-BMA 320-B-083-BMA 014-Z-358-BMA 014-C-203-BMA 320-B-092-BMA 320-B-085-BMA
8	1	Seat assembly Viton Teflon Kalrez Buna-N	715-Z-245-AAA 715-Z-041-AAA 715-Z-162-AAA 715-Z-246-AAA
9	1	Lower guide spring	820-Z-073-BBA
10	1	O-ring valve seal Viton Teflon Buna-N	375-B-016-QTA 375-B-016-QMA 375-B-016-SUA
11	1	Filflix plate	613-E-444-ACJ
12	1	Coil	185-Z-128-AAA
13	1	Coil housing	441-Z-180-AAA
14	1	Nut	575-Z-011-ACJ
15	1	Outlet adapters 1/4" tube comp. fittings 1/8" tube comp. fittings 1/4" VCR 1/4" NPT 6 mm tube comp. fittings 3/8" tube comp. fittings	320-B-079-BMA 320-B-082-BMA 014-Z-357-BMA 014-C-202-BMA 320-B-091-BMA 320-B-150-BMA
16	1	Plunger assy	622-Z-108-AAA
17	1	O-ring filter bushing Viton Teflon Buna-N	375-B-109-QTA 375-B-109-QMA 375-B-109-SUA
18	1	O-ring under orifice Viton Teflon Buna-N	375-G-042-QTA 375-G-042-QMA 375-G-042-SUA
19	1	Orifice 0,0013" 0,002" 0,003" 0,004" 0,007" 0,010" 0,014" 0,020" 0,028" 0,032" 0,048" 0,052" 0,067"	577-Z-363-BMT 577-Z-364-BMT 577-Z-365-BMT 577-Z-366-BMT 577-Z-368-BMT 577-Z-369-BMT 577-Z-401-BMT 577-Z-370-BMT 577-Z-371-BMT 577-Z-372-BMT 577-Z-137-BMT 577-Z-138-BMA 577-Z-139-BMA

5-1 RECOMMENDED SPARE PARTS 5850TR WITH N.C. VALVE, 100 BAR (continued)

		Min. full scale Max. full scale	
20 + 21	1	Restrictor assy 6,1 8,7 ml _n /min Restrictor assy 8,6 12,1 ml _n /min	110-Z-159-BMA 110-Z-160-BMA
21		$\begin{array}{cccccccccccccccccccccccccccccccccccc$	110-Z-161-BMA 110-Z-162-BMA 110-Z-163-BMA 110-Z-164-BMA 110-Z-165-BMA
		$\begin{array}{cccccccccccccccccccccccccccccccccccc$	110-Z-166-BMA 110-Z-167-BMA 110-Z-168-BMA 110-Z-169-BMA 110-Z-170-BMA
		Restrictor assy 349 494 ml _n /min Restrictor assy 488 691 ml _n /min Restrictor assy 683 967 ml _n /min Restrictor assy 958 1360 ml _n /min Restrictor assy 1340 1890 ml _n /min	110-Z-171-BMA 110-Z-231-BMA 110-Z-232-BMA 110-Z-233-BMA 110-Z-234-BMA
		Restrictor assy 1870 2650 ml _n /min Restrictor assy 2620 3710 ml _n /min Restrictor assy 3670 5200 ml _n /min Restrictor assy 5140 7300 ml _n /min Restrictor assy 7200 10200 ml _n /min	110-Z-235-BMA 110-Z-236-BMA 110-Z-237-BMA 110-Z-238-BMA 110-Z-239-BMA
		Restrictor assy 10100 14300 ml _n /min Restrictor assy 14100 20000 ml _n /min Restrictor assy 19800 28000 ml _n /min	110-Z-228-BMA 110-Z-226-BMA 110-Z-224-BMA
23	1	P.C. Board N.C.; neg. valve volt, Card Edge conn. 0-5Vdc P.C. Board N.C.;	097-B-107-ZZZ
		pos. valve volt, sub. "D"-conn. 0-5Vdc P.C. Board N.O.; neg. valve volt, Card Edge conn. 0-5Vdc	097-B-115-ZZZ 097-B-151-ZZZ
		P.C. Board N.O.; pos. valve volt, sub "D"-conn. 0-5Vdc	097-B-156-ZZZ
30	2	Cap for trimpots	620-Z-434-SXA

5-1-1 RECOMMENDED SPARE PARTS 5850TR WITH N.O. VALVE, 100 BAR

Ref. no.	Quantity required	Description	Part number
1	1	Transducer body	092-B-063-BMA
23	1	P.C. Board neg. valve volt. Card Edge conn. pos valve volt. Card Edge conn. pos valve volt. sub "D" conn.	097-B-151-ZZZ 097-B-152-ZZZ 097-B-156-ZZZ
40	1	Nut	573-Q-074-ACD
41	1	O-ring sleeve seal Viton Teflon	375-B-012-QTA 375-B-012-QMA
42	1	Plunger extension	830-Z-045-BMA
43	1	Ring	724-Z-202-AAA
44	1	Seat assembly - Kalrez	715-Z-197-AAA
45	1	Plunger assy	622-Z-110-CEA
46	1	Spacer 0,05 mm	810-A-303-BMA
47	1	Spacer 0,2 mm	810-A-304-BMA

5-1-2 RECOMMENDED SPARE PARTS 5850TR WITH N.C. VALVE, 300 BAR

Ref. no.	Quantity required	Description	Part number
1	1	Transducer body	092-B-064-BMA
11	1	Filflix Plate	613-E-452-ACJ
16	1	Plunger assy	622-Z-111-AAA

5-1-3 SERVICE TOOLS

Quantity required	Description	Part number
1	5850 M.F.C. toolkit	778-D-017-AAA
1	Stem removal tool	908-Z-048-AAA
1	Orifice removal tool	908-Z-035-AAA

SECTION 6 MODELLISTING

	THERMAL MASS BROOKS INSTRUMENT B.V 5850TR - METERS & CONTROLLERS							
BASE MODEL NUMBER			MBER		DESCRIPTION			
5850TR/F			MASS FLOW METER & CONTROLLER					
					FULL SCALE RANGES FROM 10 mln/min UPTO 20 ln/min N2			
					O-RING/VALVE SEAT MATERIAL			
Α					VITON			
В	В			BUNA				
С	С				TEFLON/KALREZ (KALREZ ONLY FOR THE VALVE SEAT)			
D	D				KALREZ (INCLUDING ADAPTERS)			
Е	≣				TEFLON			
Z	Z				SPECIFY			
					VALVE TYPE			
	0				NONE (METER ONLY) (300 BAR RATING)	Deduct:		
	1				NORMALLY CLOSED (100 BAR RATING)			
	2				NORMALLY OPENED (100 BAR RATING)			
					ELECTRICAL CONNECTIONS			
		С			0-5 VDC I/O			
		D			4-20 mA I/O			
		Е			0-20 mA I/O			
	Z			SPECIFY				
					MECHANICAL CONNECTIONS			
			1		WITHOUT ADAPTORS (9/16"-18" UNF)			
			2		1/4" TUBE COMPRESSION FITTINGS			
			3		1/8" TUBE COMPRESSION FITTINGS			
			4		1/4" VCR (100 BAR)			
			5		1/4" VCO (100 BAR)			
			6		1/4" NPT (MAX. 300 BAR)			
			7		6mm TUBE COMPRESSION FITTINGS			
	9			SPECIFY				
				INTERCONNECTION CABLE				
		0	NO CABLE					
			В	MATING CONNECTOR ONLY				
			D	3m ROUND CABLE WITH MATING "D" CONNECTORS				
l —		E	6m ROUND CABLE WITH MATING "D" CONNECTORS					
		F	12m ROUND CABLE WITH MATING "D" CONNECTORS					
Z		Z	SPECIFY					
					POWER SUPPLY INPUT			
					2 + 24 Vdc (standard)			
					3 + 15 Vdc only			
					9 SPECIFY			
	5850T	R/F A	1 C 2	E1 :	TYPICAL MODEL NUMBER			

ACCESSORIES & OPTIONS:

* FOR GASES WHICH CLOG AND CONTAMINATE THE MFC EASILY, AN ANTI-CLOG LAMINAR

FLOW ELEMENT MUST BE ORDERED.

FLOWRANGES UP TO 3460 mln/min N2, ADD:

- * INTERCONNECTION CABLE UP TO 25m LENGTH, ADD PER METER
- * CERTIFIED FOR USE IN ZONE-2 HAZARDOUS AREA
- * LASER WELDED SENSOR FOR AMONGST OTHERS, H2S APPLICATIONS

Installation and Operation Manual

X-TMF-5850TR-15-MFC-eng PN 541-C-015-AAG April, 2008

Model 5850TR

7-1 General

This section contains the procedures for the receipt and installation of the instrument. See Section 1 for dimensional and connection requirements. Do not attempt to start the system until the instrument has been permanently installed. It is important that the start-up procedures be followed in the exact sequence presented.

7-2 Receipt of Equipment

When the instrument is received, the outside packing case should be checked for damage incurred during shipment. If the packing case is damaged, the local carrier should be notified at once regarding his liability. A report should be submitted to your nearest Product Service Department.

Brooks Instrument

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Fax (215) 362-3745
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www.BrooksInstrument.com

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 6710 BK Ede, Netherlands
 Fax 011-81-3-5633-7101

 Tel 31-318-549-300
 Email: BrooksAs@EmersonProcess.com

Fax 31-318-549-309

E-mail: BrooksEu@EmersonProcess.com

Remove the envelope containing the packing list. Carefully remove the instrument from the packing case. Make sure spare parts are not discarded with the packing materials. Inspect for damaged or missing parts.

Brooks Instrument

7-3 Recommended Storage Practice

If intermediate or long-term storage of equipment is required, it is recommended that the equipment be stored in accordance with the following:

- a. Within the original shipping container.
- b. Stored in a sheltered area, preferably a warm, dry, heated warehouse.
- c. Ambient temperature of 70° F (21° C) nominal, 109° F (43° C) maximum, 45° F (7° C) minimum.
- d. Relative humidity 45% nominal, 60% maximum, 25% minimum.

Upon removal from storage a visual inspection should be conducted to verify the condition of equipment is "as received".

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7-4 Return Shipment

Prior to returning any instrument to the factory visit the Brooks website www.BrooksInstrument.com for a Return Materials Authorization Number (RMA#), or contact one of the following locations:

Brooks Instrument

407 W. Vine Street
P.O. Box 903
Hatfield, PA 19440 USA
Toll Free (888) 554-FLOW (3569)
Tel (215) 362-3700
Fax (215) 362-3745
E-mail: BrooksAm@EmersonProcess.com
www.BrooksInstrument.com

Brooks Instrument

Neonstraat 3 6718 WX Ede, Netherlands P.O. Box 428 6710 BK Ede, Netherlands Tel 31-318-549-300

Brooks Instrument

1-4-4 Kitasuna Koto-Ku Tokyo, 136-0073 Japan Tel 011-81-3-5633-7100 Fax 011-81-3-5633-7101

Email: BrooksAs@EmersonProcess.com

Fax 31-318-549-309

E-mail: BrooksEu@EmersonProcess.com

Instrument must have been purged in accordance with the following:

AWARNING

Before returning the device purge thoroughly with a dry inert gas such as Nitrogen before disconnecting gas connections. Failure to correctly purge the instrument could result in fire, explosion or death. Corrosion or contamination may occur upon exposure to air.

All flow instruments returned to Brooks requires completion of Form RPR003-1, Brooks Instrument Decontamination Statement, along with a Material Safety Data Sheet (MSDS) for the fluid(s) used in the instrument. Failure to provide this information will delay processing by Brooks personnel. Copies of these forms can be downloaded from the Brooks website www.BrooksInstrument.com or are available from any Brooks Instrument location listed above.

7-5 Transit Precautions

To safeguard the instrument against transportation damage, it is recommended to keep the instrument in its factory container until ready for installation.

7-6 Removal from Storage

Upon removal of the instrument from storage, a visual inspection should be conducted to verify its "as-received" condition. If the instrument has been subject to storage conditions in excess of those recommended (See Section 7-3), it should be subjected to a pneumatic pressure test in accordance with applicable vessel codes.

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(1) TYPE EXAMINATION CERTIFICATE

- (2) Equipment and protective systems intended for use in potentially explosive atmospheres - Directive 94/9/EC
- (3) Type Examination Certificate Number: KEMA 03ATEX1531 X

Issue Number: 3

- (4) Equipment: Thermal Mass Flowmeter / Flowcontroller Model 5850TR
- (5) Manufacturer: Brooks Instrument LLC
- (6) Address: 407 West Vine Street, Hatfield, PA 19440, USA
- (7) This equipment and any acceptable variation thereto is specified in the schedule to this certificate and the documents therein referred to.
- (8) KEMA Quality B.V. certifies that this equipment has been found to comply with the Essential Health and Safety Requirements relating to the design and construction of equipment and protective systems intended for use in potentially explosive atmospheres given in Annex II to the directive.

The examination and test results are recorded in confidential test report no. 2113693-9.

(9) Compliance with the Essential Health and Safety Requirements has been assured by compliance with:

EN 60079-15: 2003

- (10) If the sign "X" is placed after the certificate number, it indicates that the equipment is subject to special conditions for safe use specified in the schedule to this certificate.
- (11) This Type Examination Certificate relates only to the design, examination and tests of the specified equipment and not to the manufacturing process and supply of this equipment.
- (12) The marking of the equipment shall include the following:



II 3 G EEx nA II T4

This certificate is issued on March 21, 2008 and, as far as applicable, shall be revised before the date of cessation of presumption of conformity of (one of) the standards mentioned above as communicated in the Official Journal of the European Union.

KEMA Quality B.V.

C.G. van Es Certification Manager

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o Integral publication of this certificate and adjoining reports is allowed. This Certificate may only be reproduced in its entirety and without any change.

Installation and Operation Manual

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LIMITED WARRANTY

Seller warrants that the Goods manufactured by Seller will be free from defects in materials or workmanship under normal use and service and that the Software will execute the programming instructions provided by Seller until the expiration of the earlier of twelve (12) months from the date of initial installation or eighteen (18) months from the date of shipment by Seller. Products purchased by Seller from a third party for resale to Buyer ("Resale Products") shall carry only the warranty extended by the original manufacturer.

All replacements or repairs necessitated by inadequate preventive maintenance, or by normal wear and usage, or by fault of Buyer, or by unsuitable power sources or by attack or deterioration under unsuitable environmental conditions, or by abuse, accident, alteration, misuse, improper installation, modification, repair, storage or handling, or any other cause not the fault of Seller are not covered by this limited warranty, and shall be at Buyer's expense.

Goods repaired and parts replaced during the warranty period shall be in warranty for the remainder of the original warranty period or ninety (90) days, whichever is longer. This limited warranty is the only warranty made by Seller and can be amended only in a writing signed by an authorized representative of Seller.

BROOKS LOCAL AND WORLDWIDE SUPPORT

Brooks Instrument provides sales and service facilities around the world, ensuring quick delivery from local stock, timely repairs and local based sales and service facilities.

Our dedicated flow experts provide consultation and support, assuring successful applications of the Brooks flow measurement and control products.

Calibration facilities are available in local sales and service offices. The primary standard calibration equipment to calibrate our flow products is certified by our local Weights and Measures Authorities and traceable to the relevant international standards.

START-UP SERVICE AND IN-SITU CALIBRATION

Brooks Instrument can provide start-up service prior to operation when required.

For some process applications, where ISO-9001 Quality Certification is important, it is mandatory to verify and/or (re)calibrate the products periodically. In many cases this service can be provided under in-situ conditions, and the results will be traceable to the relevant international quality standards.

CUSTOMER SEMINARS AND TRAINING

Brooks Instrument can provide customer seminars and dedicated training to engineers, end users and maintenance persons. Please contact your nearest sales representative for more details.



